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Term	Documents
FLOATING.JPAB.	36975
FLOATINGS.JPAB.	18
AMORPHOUS.JPAB.	32194
AMORPHOU.JPAB.	2
SILICON.JPAB.	104568
SILICONS.JPAB.	173
CARBIDE.JPAB.	19253
CARBIDES.JPAB.	2109
INSULAT?	0
INSULATD.JPAB.	6
(FLOATING AND (AMORPHOUS ADJ1 SILICON ADJ1 CARBIDE ADJ4 (INSULAT? OR DIELECTRIC\$))).JPAB.	0

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Refine Search:floating and (amorphous adj1 silicon
adj1 carbide adj4 (insulat? or
dielectric\$))[Clear](#)**Search History****Today's Date: 10/19/2000**

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
JPAB	floating and (amorphous adj1 silicon adj1 carbide adj4 (insulat? or dielectric\$))	0	<u>L7</u>
JPAB	memory and (amorphous adj1 silicon adj1 carbide adj4 (insulat? or dielectric\$))	0	<u>L6</u>
JPAB	gate and (amorphous adj1 silicon adj1 carbide adj4 (insulat? or dielectric\$))	0	<u>L5</u>
USPT	memory and (amorphous adj1 silicon adj1 carbide adj4 (insulat? or dielectric\$))	0	<u>L4</u>
USPT	l1 and (amorphous adj1 silicon adj1 carbide adj4 (insulat? or dielectric\$))	0	<u>L3</u>
USPT	l1 and (amorphous adj1 silicon adj1 carbide)	5	<u>L2</u>
USPT	floating adj1 gate	6904	<u>L1</u>